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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Masao KONDO et al.**

Group Art Unit: **2814**

Serial No.: **10/755,448**

Examiner: **Thao X Le**

Filed: **January 13, 2004**

Confirmation No.: **1084**

For: **SEMICONDUCTOR DEVICE, METHOD OF FORMING
EPITAXIAL FILM, AND LASER ABLATION DEVICE**

Attorney Docket Number: **020296A**

Customer Number: **38834**

AMENDMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: June 27, 2005

Sir:

This paper is filed in response to the Office Action dated March 30, 2005.

Amendments to the Claims begin on page 2 of this paper.

Amendments to the Drawings begin on page 6 of this paper.

Remarks begin on page 7 of this paper.